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In re application of

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Yoshihiro GUNJI et al.

Serial No. 09/917,732

Filed July 31, 2001

SUBSTRATE HOLDING APPARATUS AND SUBSTRATE POLISHING APPARATUS

Docket No. 2001-1075A

Group Art Unit 2812

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEE FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975.

RESPONSE TO NOTICE TO FILE CORRECTED APPLICATION PAPERS

Assistant Commissioner for Patents, Washington, D.C.

Sir:

OCT 3 0 2001 Attached hereto please find one set of formal drawings to the above-referenced U.S. patent application including the appropriate margins. Also enclosed is a copy of the Notice to File Corrected Application papers.

Respectfully submitted,

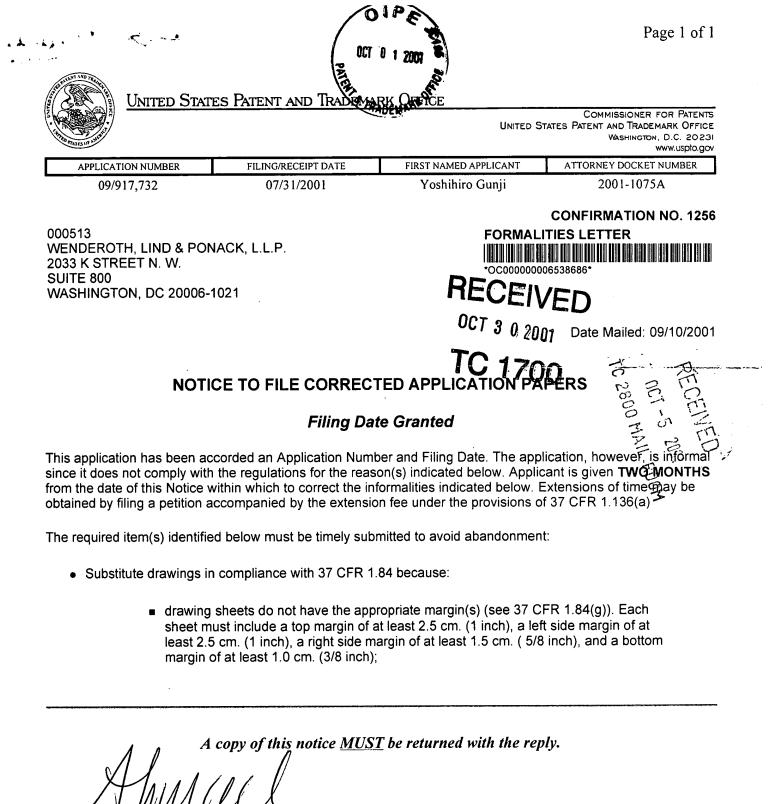
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